



Designation: F 76 – 86 (Reapproved 1996)^{€1}

Standard Test Methods for Measuring Resistivity and Hall Coefficient and Determining Hall Mobility in Single-Crystal Semiconductors¹

This standard is issued under the fixed designation F 76; the number immediately following the designation indicates the year of original adoption or, in the case of revision, the year of last revision. A number in parentheses indicates the year of last reapproval. A superscript epsilon (€) indicates an editorial change since the last revision or reapproval.

€¹ NOTE—Keywords were added editorially in February 1997.

1. Scope

1.1 These test methods cover two procedures for measuring the resistivity and Hall coefficient of single-crystal semiconductor specimens. These test methods differ most substantially in their test specimen requirements.

1.1.1 *Test Method A, van der Pauw (1)*²—This test method requires a singly connected test specimen (without any isolated holes), homogeneous in thickness, but of *arbitrary* shape. The contacts must be sufficiently small and located at the periphery of the specimen. The measurement is most easily interpreted for an isotropic semiconductor whose conduction is dominated by a single type of carrier.

1.1.2 *Test Method B, Parallelepiped or Bridge-Type*—This test method requires a specimen homogeneous in thickness and of *specified* shape. Contact requirements are specified for both the parallelepiped and bridge geometries. These test specimen geometries are desirable for anisotropic semiconductors for which the measured parameters depend on the direction of current flow. The test method is also most easily interpreted when conduction is dominated by a single type of carrier.

1.2 These test methods do not provide procedures for shaping, cleaning, or contacting specimens; however, a procedure for verifying contact quality is given.

NOTE 1—Practice F 418 covers the preparation of gallium arsenide phosphide specimens.

1.3 The method in Practice F 418 does not provide an interpretation of the results in terms of basic semiconductor properties (for example, majority and minority carrier mobilities and densities). Some general guidance, applicable to certain semiconductors and temperature ranges, is provided in the Appendix. For the most part, however, the interpretation is left to the user.

1.4 Interlaboratory tests of these test methods (Section 19) have been conducted only over a limited range of resistivities

and for the semiconductors, germanium, silicon, and gallium arsenide. However, the method is applicable to other semiconductors provided suitable specimen preparation and contacting procedures are known. The resistivity range over which the method is applicable is limited by the test specimen geometry and instrumentation sensitivity.

1.5 The values stated in acceptable metric units are to be regarded as the standard. The values given in parentheses are for information only. (See also 3.1.4.)

1.6 *This standard does not purport to address all of the safety concerns, if any, associated with its use. It is the responsibility of the user of this standard to establish appropriate safety and health practices and determine the applicability of regulatory limitations prior to use.*

2. Referenced Documents

2.1 ASTM Standards:

D 1125 Test Methods for Electrical Conductivity and Resistivity of Water³

E 177 Practice for Use of the Terms Precision and Bias in ASTM Test Methods⁴

F 26 Test Methods for Determining the Orientation of a Semiconductive Single Crystal⁵

F 43 Test Methods for Resistivity of Semiconductor Materials⁵

F 47 Test Method for Crystallographic Perfection of Silicon by Preferential Etch Techniques⁵

F 418 Practice for Preparation of Samples of the Constant Composition Region of Epitaxial Gallium Arsenide Phosphide for Hall Effect Measurements⁵

2.2 SEMI Standard:

C1 Specifications for Reagents⁶

3. Terminology

3.1 Definitions:

3.1.1 *Hall coefficient*—the ratio of the Hall electric field (due to the Hall voltage) to the product of the current density

¹ These test methods are under the jurisdiction of ASTM Committee F-1 on Electronics and are the direct responsibility of Subcommittee F01.15 on Gallium Arsenide.

Current edition approved Oct. 31, 1986. Published December 1986. Originally published as F 76 – 67T. Last previous edition F 76 – 84.

² The boldface numbers in parentheses refer to the list of references at the end of these test methods.

³ *Annual Book of ASTM Standards*, Vol 11.01.

⁴ *Annual Book of ASTM Standards*, Vol 14.02.

⁵ *Annual Book of ASTM Standards*, Vol 10.05.

⁶ Available from Semiconductor Equipment and Materials Institute, 625 Ellis St., Suite 212, Mountain View, CA 94043.